

**Notice of References Cited**

Application/Control No.

09/996,695

Applicant(s)/Patent Under  
Reexamination  
ZHOU ET AL.

Examiner

Kishor Mayekar

Art Unit

1753

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**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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	B	US-5,906,721	05-1999	Bojkov et al.	204/491
	C	US-6,258,237	07-2001	Gal-Or et al.	204/548
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	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

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**NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Affoune, A. M. et al. , "Electrophoretic Deposition of Nanosized Diamond particles", Langmuir 2001, 17, 547-551.
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\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.